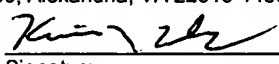


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
 DESIGNATED/ELECTED OFFICE (DO/EO/US)  
 CONCERNING A SUBMISSION UNDER 35 U.S.C. 371**

In re Application of: Ling CHEN, et al.	§ § §	Int'l Application No.: PCT/US2004/016715
Serial No.: to be assigned	§ §	Int'l Filing Date: 27 May 2004 (27.05.2004)
Filed: herewith	§ §	Priority Date: 27 May 2003 (27.05.2003)
For: METHOD AND APPARATUS FOR GENERATING A PRECURSOR FOR A SEMICONDUCTOR PROCESSING SYSTEM	§ § § § §	

MAIL STOP PCT  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10	
I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on August 24, 2006, with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV763975127US, addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
8/24/06 Date	 Signature

**PRELIMINARY AMENDMENT**

Prior to examination, please amend the above-identified application as follows.

**Amendments to the Specification** begin on page 2 of this paper. **The Pending Claims** are reflected in the listing of claims which begins on page 3 of this paper. **Remarks** begin on page 9 of this paper.